

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

icant(s): Iijima, Y., et al. Appl. No.: 09/857,912

Conf. No.:

2711

Filed:

Title:

SEP 1 1 2003

June 11, 2001 POLYCRYSTALLINE THIN FILM AND METHOD OF PRODUCING THE

SAME AND OXIDE SUPERCONDUCTOR AND METHOD OF PRODUCING

THE SAME

Art Unit:

1725

Examiner:

Cooke, Colleen P.

Docket No.:

113197-10

Mail Stop

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

CERTIFICATE OF MAILING BY FIRST CLASS MAIL UNDER 37 CFR 1.8

Sir:

I hereby certify that the following documents relating to the above-identified application:

- 1. Petition for Extension of Time (duplicate);
- 2. Response to Office Action (9 pages);
- 3. Copy of computer generated English language translation of Iijima JP '967 (17 pages);
- 4. check in the amount of \$110.00;
- 5. return receipt postcard.

are being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to:

Mail Stop Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

on September 8, 2003.

Respectfulk subnitted.

/BOYID &/LLØYID LLC

Varye of Person Mailing Correspondence

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